

EXPEDITED PROCEDURE – EXAMINING GROUP 1763

S/N 09/652,713

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant: | Trung T. Doan | Examiner: | Sylvia MacArthur |
| Serial No.: | 09/652,713 | Group Art Unit: | 1763 |
| Filed: | August 31, 2000 | Docket No.: | 303.928US5 |
| Title: | CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING | | |

AMENDMENT & RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Final Office Action mailed January 19, 2007, please amend the application as follows: